

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application of:
Tayanaka

Serial No.: 10/067,486

Filed: February 4, 2002

For: **SEMICONDUCTOR SUBSTRATE
AND THIN FILM SEMICONDUCTIVE
MEMBER, AND METHOD FOR
MAKING THEREOF**



Examiner: To be determined

Group Art Unit: 2822

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

Prior to examination on the merit, please amend the above-captioned application as follows:

In the Specification

On page 11, please delete the following paragraph:

--FIG. 22 is a schematic cross-sectional view of another porous layer in Example 4 in accordance with the present invention.--

Respectfully submitted,

SONNENSCHN NATH & ROSENTHAL

By: _____

Jeffrey F. Craft

Registration No. 30,044

SONNENSCHN NATH & ROSENTHAL
P.O. Box #061080
Wacker Drive Station, Sears Tower
Chicago, IL 60606